



PATENT

**In the United States Patent and Trademark Office**

Applicant: )  
LEE et al. )  
Application No. 10/674,319 )  
Filed: September 29, 2003 )  
For: METHOD AND APPARATUS OF A )  
VARIABLE HEIGHT AND CONTROLLED )  
FLUID FLOW PLATEN IN A CHEMICAL )  
MECHANICAL POLISHING SYSTEM )

Examiner: Unassigned  
Art Unit: 3723  
Docket No. LAM2P434  
Date: February 12, 2004

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on February 12, 2004.

Signed: \_\_\_\_\_

Kay Harlow


**Separate Letter to the Official Draftsperson**

Commissioner for Patents  
Mail Stop PGPUB Drawings  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice to File Corrected Application Papers dated December 22, 2003, indicating that formal drawings are now required, enclosed herewith are the formal drawings (Figures 1, 2A, 2B, 3, 4A-1, 4A-2, 4A-3, 4B, 4C-1, 4C-2, 4C-3, 5A, 5B, 6, 7, 8 and 9), for the above-referenced case. If the draftsperson has any questions concerning these drawings, please contact the undersigned at the number set forth below. If any fees are due in connection with the filing of these drawings, please charge such fees to deposit account 50-0805 (Order No. LAM2P434).

Respectfully submitted,  
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